

IN THE UNITED STATES RECEIVING OFFICE (RO/US)

APPLICANT : KIM, Dong-Soo

APPL'N SERIAL NO. : Not yet assigned

APPL'N FILED : Herewith

FOR : MAGNETRON PLASMA ETCHING APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

S I R:

Prior to calculation of the filing fee in the above-identified application, please amend the application as follows. The amendments are presented with strikeout and underlining to indicate changes made pursuant to current practice.